



AF #2872

Docket No. 47513CPA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**APPLICANT:** Peter W. J. Jones **EXAMINER:** T. Nguyen  
**SERIAL NO.:** 09/094,052 **GROUP:** 2872  
**FILED:** June 9, 1998  
**FOR:** METHODS FOR REFLECTION REDUCTION

RECEIVED  
OCT 23 2001  
TC 2800 MAIL ROOM

Patent  
10/23/01

#20/09  
Amended  
X11E  
Inclined  
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CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington, D.C. 20231 on October 17, 2001.

Annemarie Serrecchia  
Annemarie Serrecchia

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, DC 20231

**RESPONSE TO FINAL OFFICE ACTION**

Sir:

The following is in response to the final Office Action mailed April 17, 2001 in the above referenced application.

Please amend the subject application as follows:

IN THE CLAIMS:

1. An apparatus for reducing reflection on a surface comprising:  
a plurality of concentric circular vanes, mounted in front of said reflective surface, each of said vanes including a first end proximate said surface, and a second end away from said surface, wherein said first ends of said plurality of vanes are spaced apart from each other at a different distance than said second ends of said plurality of vanes are spaced apart from each other, and wherein said first ends of said plurality of vanes are spaced further apart from each other than said second ends of

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